

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	Substrate treating method and apparatus
First Named Inventor/Applicant Name:	Hajime Shirakawa
Customer Number:	2352
Filer:	James Alan Finder/RaShida Williams
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment After Final	00811972.PDF	151167	no	4

Warnings:

Information:	
Total Files Size (in bytes):	151167
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